

## Topological Surface States Originated Spin-Orbit Torques in $\text{Bi}_2\text{Se}_3$

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The three dimensional topological insulator bismuth selenide ( $\text{Bi}_2\text{Se}_3$ ) is expected to possess strong spin-orbit coupling and spin-textured topological surface states and, thus, exhibit a high charge to spin current conversion efficiency. We evaluate spin-orbit torques in  $\text{Bi}_2\text{Se}_3/\text{Co}_{40}\text{Fe}_{40}\text{B}_{20}$  devices at different temperatures by spin torque ferromagnetic resonance measurements. As the temperature decreases, the spin-orbit torque ratio increases from  $\sim 0.047$  at 300 K to  $\sim 0.42$  below 50 K. Moreover, we observe a significant out-of-plane torque at low temperatures. Detailed analysis indicates that the origin of the observed spin-orbit torques is topological surface states in  $\text{Bi}_2\text{Se}_3$ . Our results suggest that topological insulators with strong spin-orbit coupling could be promising candidates as highly efficient spin current sources for exploring the next generation of spintronic applications.

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The realization of functional devices such as nonvolatile memories and spin logic applications is of key importance in spintronic research [1]. The functions of these magnetic devices require highly efficient magnetization manipulation in a ferromagnet (FM), which can be achieved by an external magnetic field or a spin-polarized current by spin transfer torque. Recent advances have demonstrated that pure spin currents resulting from charge currents via spin-orbit coupling in heavy metals, such as Pt [2–7], Ta [8–10], and W [11], can produce strong spin-orbit torques on the adjacent magnetic layers. The reported amplitude of spin Hall angles (i.e., efficiency of spin-orbit torques) in Pt and Ta is in the range of  $\sim 0.012$  to  $\sim 0.15$  and in W is  $\sim 0.33$ . The exploration for new materials exhibiting new physics and possessing an even higher conversion efficiency between the charge current density ( $J_c$ ) and spin current density ( $J_s$ ) is crucial to exploit next-generation spintronic devices.

The three-dimensional (3D) topological insulators (TIs) are a new class of the quantum state of materials that have an insulating bulk and spin-momentum-locked metallic surface states [12–14]. They exhibit strong spin-orbit coupling and are expected to show a high charge to spin current conversion efficiency. So far, by extensively employing angle-resolved photoemission spectroscopy (ARPES) and spin-resolved ARPES, the Dirac cones and the helical spin-polarized topological surface states (TSSs) have been observed and the topological nature has been confirmed in TIs [15,16]. The surface state dominant conduction has also been confirmed by thickness-dependent transport measurements in  $\text{Bi}_2\text{Se}_3$  [17].

The TSS in TI is immune to the nonmagnetic impurities due to the time reversal symmetry protection. Although a gap opening in the TSS dispersion was reported in  $\text{Bi}_2\text{Se}_3$  doped with Fe in the bulk [18], most recently reports have

confirmed that the TSS is intact in  $\text{Bi}_2\text{Se}_3$  covered with Fe [19,20] or Co [21] with in-plane magnetic anisotropy. The spin-dependent transport is known to be significant near the Fermi level in the  $\text{Bi}_2\text{Se}_3$  surface states. However, limited spin-dependent transport experiments have been focused on TI and FM heterostructures. Only recently, spin-orbit effects have been reported by spin pumping measurements [22–24] and magnetoresistance measurements [25,26]. Direct charge current-induced spin-orbit torque on the FM layer has been demonstrated by a spin torque ferromagnetic resonance (ST-FMR) measurement only at room temperature [27] and magnetization switching at cryogenic temperature [28]. It is known that for  $\text{Bi}_2\text{Se}_3$  the bulk channel provides an inevitable contribution to transport at room temperature and may diminish the signals of spin-orbit torques arising from surface states. At low temperatures, however, the surface contribution should become significant [17], and spin-orbit torques in TI and FM heterostructures should be enhanced [28].

In this work, we adopt extensively studied  $\text{Bi}_2\text{Se}_3$  as the TI layer and investigate the temperature dependence of charge-spin conversion efficiency, spin-orbit torque ratio ( $\theta_{\parallel} = J_s/J_c$ ), by the ST-FMR technique in  $\text{Bi}_2\text{Se}_3$  and  $\text{Co}_{40}\text{Fe}_{40}\text{B}_{20}$  heterostructures. In this structure, the spin currents generated from charge currents flowing in  $\text{Bi}_2\text{Se}_3$  are injected into a ferromagnetic  $\text{Co}_{40}\text{Fe}_{40}\text{B}_{20}$  layer and exert torques on it. It must be pointed out that the spin-orbit torques could be attributed to either the spin Hall effect (SHE) in the  $\text{Bi}_2\text{Se}_3$  bulk, Rashba-split states at the interface [29–31], or  $\text{Bi}_2\text{Se}_3$  topological surface states [23,27,28,31]. We find that  $\theta_{\parallel}$  drastically increases when the temperature decreases to  $\sim 50$  K. As the temperature decreases furthermore,  $\theta_{\parallel}$  reaches up to  $\sim 0.42$ , which is  $\sim 10$  times larger than that at 300 K. In addition, a significant out-of-plane torque is extracted at low

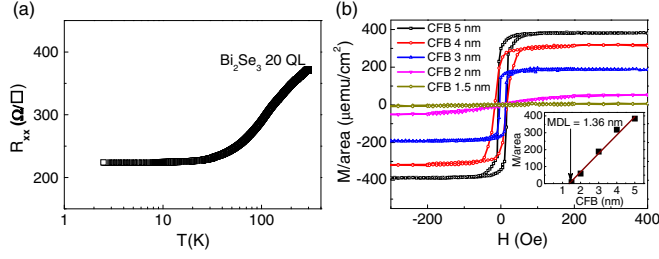


FIG. 1 (color online). (a) Temperature-dependent sheet resistivity of  $\text{Bi}_2\text{Se}_3$  films (20 QL). (b) The magnetization versus field ( $H$ ) for  $\text{Bi}_2\text{Se}_3$ (20 QL)/CFB ( $t$  (nominal thickness  $t = 1.5, 2, 3, 4$ , and  $5$  nm) at room temperature. The inset shows the magnetization per unit area versus CFB thickness.

temperatures. We argue that our observations could be correlated with the TSS in our  $\text{Bi}_2\text{Se}_3$  and  $\text{Co}_{40}\text{Fe}_{40}\text{B}_{20}$  heterostructures.

A 20 quintuple layer (QL, 1 QL  $\approx 1$  nm) of  $\text{Bi}_2\text{Se}_3$  films is grown on  $\text{Al}_2\text{O}_3$  (0001) substrates by using a custom-designed SVTA MOSV-2 molecular beam epitaxy system with a base pressure  $< 3 \times 10^{-10}$  Torr. The detailed procedures for  $\text{Bi}_2\text{Se}_3$  thin film growth can be found in previous reports [17,32]. The temperature-dependent resistivity of  $\text{Bi}_2\text{Se}_3$  film is measured by the four-probe method. Figure 1(a) shows a typical characteristic of  $\text{Bi}_2\text{Se}_3$  that the sheet resistivity decreases as the temperature decreases and then saturates at temperature  $< 30$  K [17,33]. High resistivity  $\text{Co}_{40}\text{Fe}_{40}\text{B}_{20}$  (CFB) is chosen as the FM layer in order to minimize the current shutting effect through the FM layer. We have prepared five  $\text{Bi}_2\text{Se}_3/\text{CFB}(t)$  samples (thickness  $t = 1.5, 2, 3, 4$ , and  $5$  nm) and measured their magnetization response as a function of the external magnetic field as plotted in Fig. 1(b). From the inset in Fig. 1(b), magnetic dead layer (MDL) in  $\text{Bi}_2\text{Se}_3/\text{CFB}$  samples is estimated to be  $1.36$  nm, similar to a recent report in which the Co dead layer at the interface of  $\text{Bi}_2\text{Se}_3$  and Co is  $\sim 1.2$  nm [34].

The ST-FMR devices are fabricated by the following process. First, a  $5$  nm CFB layer is sputtered onto the  $\text{Bi}_2\text{Se}_3$  film at room temperature with a base pressure of  $3 \times 10^{-9}$  Torr followed by a  $\text{MgO}(1 \text{ nm})/\text{SiO}_2(3 \text{ nm})$  capping layer to prevent CFB from oxidation. Then the film is patterned into rectangular-shaped microstrips (dotted blue line) with dimensions of  $L(130 \mu\text{m}) \times W(10\text{--}20 \mu\text{m})$  by photolithography and Ar ion milling as shown in Fig. 2(a). In the next step, coplanar waveguides are fabricated. Different gaps ( $10\text{--}55 \mu\text{m}$ ) between the ground ( $G$ ) and signal ( $S$ ) electrodes are designed to tune the device impedance  $\sim 50 \Omega$ . A radio frequency (rf) current ( $I_{\text{rf}}$ ) with frequencies from  $7$  to  $10$  GHz and a nominal power of  $15$  dBm from a signal generator (SG, Agilent E8257D) is applied to the  $\text{Bi}_2\text{Se}_3/\text{CFB}$  bilayer via a bias tee, and the ST-FMR signal ( $V_{\text{mix}}$ ) is detected simultaneously by a lock-in amplifier. An in-plane external magnetic field ( $H_{\text{ext}}$ ) is applied at a fixed angle ( $\theta_H$ ) of  $35^\circ$

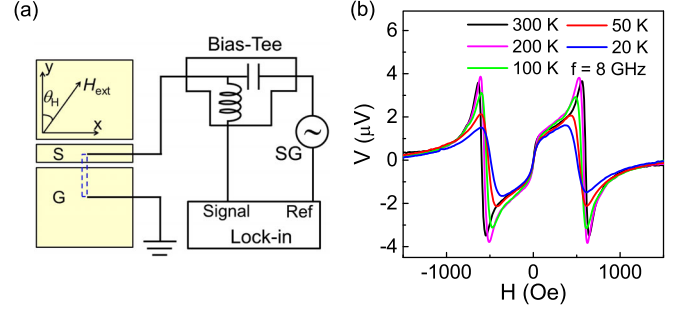


FIG. 2 (color online). (a) The schematic diagram of the ST-FMR measurement, illustrating a bias tee, lock-in amplifier, rf signal generator (SG), and ST-FMR device with a  $\text{Bi}_2\text{Se}_3/\text{CFB}$  ( $5$  nm). The microstrip is denoted by a dashed blue rectangle. (b) The measured ST-FMR signals from a  $\text{Bi}_2\text{Se}_3/\text{CFB}$  ( $5$  nm) device ( $D1$ ) at different temperatures.

with respect to the microstrip length direction [6]. We present the data from three different devices, denoted as  $D1$ ,  $D2$ , and  $D3$ .

Figure 2(b) shows the measured ST-FMR signals from  $D1$  at different temperatures ranging from  $20$  to  $300$  K.  $V_{\text{mix}}$  can be fitted by a sum of symmetric and antisymmetric Lorentzian functions:  $V_{\text{mix}} = V_s F_{\text{sym}}(H_{\text{ext}}) + V_a F_{\text{asym}}(H_{\text{ext}})$  [3,6,27]. From fitting, the symmetric component  $V_s$  (corresponding to in-plane torque  $\tau_{\parallel}$  on CFB) and antisymmetric component  $V_a$  (corresponding to total out-of-plane torque  $\tau_{\perp}$ ) can be determined, simultaneously.

The spin-orbit torque ratio from ST-FMR measurements can be characterized by two methods. One is to obtain  $\theta_{\parallel}$  from the analysis of  $V_s/V_a$  via  $\theta_{\parallel} = (V_s/V_a)(e\mu_0 M_s t d / \hbar)[1 + (4\pi M_{\text{eff}}/H_{\text{ext}})]^{1/2}$  [3], where  $t$  and  $d$  represent the thickness of the CFB and  $\text{Bi}_2\text{Se}_3$  layer, respectively.  $M_s$  is the saturation magnetization of CFB, and  $M_{\text{eff}}$  is the effective magnetization. This method (denoted as “by  $V_s/V_a$ ” hereafter) is to date widely used in ST-FMR measurements of heavy metals Pt (or Ta)/FM bilayers [3,6,8]. However, one assumption of this method is that the  $V_a$  is only attributed to the Oersted field-induced out-of-plane torque. However, in the case of a TI, the TSS in TI and/or Rashba-split states at the interface could also contribute to  $V_a$ , therefore, we cannot estimate the actual  $\theta_{\parallel}$  value by  $V_s/V_a$ . On the other hand, the second method can avoid such an issue by analyzing only the symmetric component  $V_s$  (denoted as “by  $V_s$  only” hereafter) using the following equations:  $V_s = -(I_{\text{rf}} \gamma \cos \theta_H / 4)(dR/d\theta_H) \tau_{\parallel} (1/\Delta) F_{\text{sym}}(H_{\text{ext}})$ ,  $\sigma_s = J_s/E = \tau_{\parallel} M_s t / E$ , and  $\theta_{\parallel} = \sigma_s / \sigma$  [6,27], where  $I_{\text{rf}}$  is the rf current flowing through the device,  $dR/d\theta_H$  is the angular-dependent magnetoresistance at  $\theta_H = 35^\circ$ ,  $\Delta$  is the linewidth of the ST-FMR signal,  $F_{\text{sym}}(H_{\text{ext}})$  is a symmetric Lorentzian,  $\tau_{\parallel}$  is the in-plane spin-orbit torque on the unit CFB moment at  $\theta_H = 0^\circ$ ,  $\sigma_s$  is the  $\text{Bi}_2\text{Se}_3$  spin Hall conductivity,  $\sigma$  is the  $\text{Bi}_2\text{Se}_3$

conductivity, and  $E$  is the microwave field across the device. The second method avoids the possible contamination to  $\theta_{\parallel}$  arising from  $V_a$ , therefore, we can extract the  $\theta_{\parallel}$  values in  $\text{Bi}_2\text{Se}_3$  by analyzing only  $V_s$ . At the same time, the total out-of-plane torque  $\tau_{\perp}$  can be derived by using  $V_a = -(I_{\text{rf}} \gamma \cos \theta_H / 4) (dR/d\theta_H) \tau_{\perp} \{ [1 + (\mu_0 M_{\text{eff}} / H_{\text{ext}})]^{1/2} / \Delta \} F_{\text{asym}}(H_{\text{ext}})$  [27], where  $F_{\text{asym}}(H_{\text{ext}})$  is an antisymmetric Lorentzian.

Figures 3(a) and 3(b) show the  $\tau_{\parallel}$  and  $\tau_{\perp}$  as functions of temperature, respectively, using the second method. Here, the  $\tau_{\parallel}$  ( $\tau_{\perp}$ ) represents the mean value for different rf frequencies. At 300 K, the  $\tau_{\parallel}$  is  $\sim 0.43$  Oe for  $D1$  ( $\sim 0.84$  Oe for  $D2$  and  $\sim 0.48$  Oe for  $D3$ ). As the temperature decreases from 300 to 100 K,  $\tau_{\parallel}$  for all three devices gradually increases. At  $\sim 50$  K,  $\tau_{\parallel}$  shows a steep increase and finally reaches  $\sim 5.25$  Oe for  $D1$  ( $\sim 4.11$  Oe for  $D2$  and  $\sim 2.26$  Oe for  $D3$ ), which is  $\sim 10$  times larger than that at 300 K. It is noteworthy that the observed drastic temperature-dependent behavior of  $\tau_{\parallel}$  is different from the recently reported results in heavy metals such as Ta [10,35] as well as Pt [6,36,37], where the damping like torque (equivalent to  $\tau_{\parallel}$  here), often argued to arise mainly from the SHE, shows a weak temperature dependence. This difference indicates the SHE mechanism may not account for the observed  $\tau_{\parallel}$  in our  $\text{Bi}_2\text{Se}_3$ /CFB. Moreover, the  $\tau_{\perp}$  shows a similar temperature-dependent behavior as  $\tau_{\parallel}$  shown in Fig. 3(b). It is worth noting that the difference in  $\tau_{\parallel}$  (and  $\tau_{\perp}$ ) among  $D1$ ,  $D2$ , and  $D3$  can be attributed to the slight variation of the  $\text{Bi}_2\text{Se}_3$ /CFB interface during the fabrication process considering recent challenges in TI film growth and device fabrication. However, a qualitatively similar temperature dependence of torques is observed in all devices.

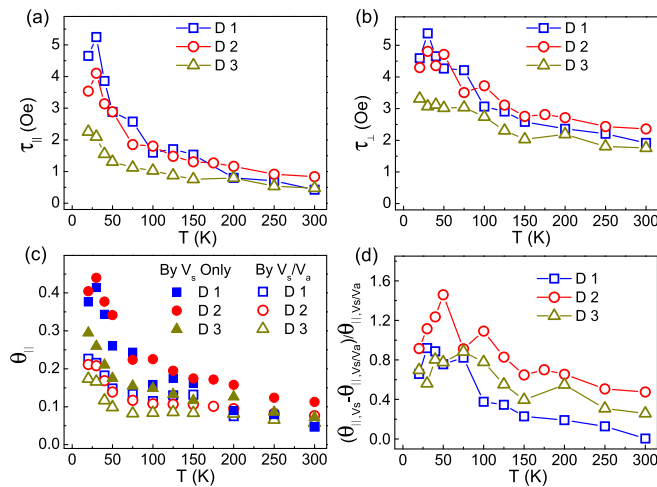


FIG. 3 (color online). Temperature dependence of (a)  $\tau_{\parallel}$ , (b)  $\tau_{\perp}$ , (c)  $\theta_{\parallel}$ , and (d)  $[\theta_{\parallel}(\text{by } V_s \text{ only}) - \theta_{\parallel}(\text{by } V_s/V_a)] / [\theta_{\parallel}(\text{by } V_s/V_a)]$  in  $\text{Bi}_2\text{Se}_3$ /CFB (5 nm) for  $D1$ ,  $D2$ , and  $D3$ . The  $\theta_{\parallel}$  is analyzed by two different methods: by  $V_s$  only and by  $V_s/V_a$ .

The  $\theta_{\parallel}$  values as a function of temperature determined by the above two methods have been shown in Fig. 3(c). From analysis by  $V_s$  only,  $\theta_{\parallel}$  is  $\sim 0.047$  for  $D1$  ( $\sim 0.113$  for  $D2$  and  $\sim 0.072$  for  $D3$ ) at 300 K and increases to  $\sim 0.158$  for  $D1$  ( $\sim 0.225$  for  $D2$  and  $\sim 0.149$  for  $D3$ ) as the temperature decreases to 100 K. In this temperature range (100–300 K),  $\theta_{\parallel}$  has similar amplitudes as the spin Hall angle in heavy metals such as Pt, Ta, and W [3,8,11,42–44]. However,  $\theta_{\parallel}$  increases sharply as the temperature decreases to  $\sim 50$  K and reaches maximum values of  $\sim 0.42$  for  $D1$  ( $\sim 0.44$  for  $D2$  and  $\sim 0.30$  for  $D3$ ) at lower temperatures, respectively. Remarkably,  $\theta_{\parallel}$  increases  $\sim 10$  times compared to that at 300 K for  $D1$ . Similarly, from the analysis by  $V_s/V_a$ ,  $\theta_{\parallel}$  also shows an abrupt increase as the temperature decreases to  $\sim 50$  K in Fig. 3(c). It is worth noting that we use the effective CFB thickness of  $t = 3.64$  nm due to the dead layer for  $\theta_{\parallel}$  estimation by  $V_s/V_a$  at different temperatures. Interestingly, as shown in Fig. 3(d), the ratio of  $[\theta_{\parallel}(\text{by } V_s \text{ only}) - \theta_{\parallel}(\text{by } V_s/V_a)] / \theta_{\parallel}(\text{by } V_s/V_a)$  obtained by two different methods increases as the temperature decreases and becomes more significant below  $\sim 50$  K, as discussed later.

In the context of spin Hall mechanism, the spin Hall angle ( $\theta_{\text{sh}}$ ) is found to be almost independent of temperature from Pt [6,36], Ta [45],  $\text{Cu}_{99.5}\text{Bi}_{0.5}$ , and  $\text{Ag}_{99}\text{Bi}_1$  [46], which is attributed to extrinsic mechanisms. In some cases,  $\theta_{\text{sh}}$  shows a gradual increase as the temperature decreases, which behaves as a typical intrinsic mechanism based on the degeneracy of  $d$  orbits by spin-orbit coupling [47,48]. In contrast, in our  $\text{Bi}_2\text{Se}_3$ /CFB, the spin-orbit torque ratio ( $\theta_{\parallel}$ ) shows an abrupt and nonlinear increase as the temperature decreases, especially below  $\sim 50$  K. Therefore, the SHE from the  $\text{Bi}_2\text{Se}_3$  bulk is probably not the dominant mechanism for our observation of the temperature-dependent spin-orbit torque (ratio) in  $\text{Bi}_2\text{Se}_3$ /CFB. From the measured ST-FMR signals as shown in Fig. 2(b), we also find that the Rashba-split state at the  $\text{Bi}_2\text{Se}_3$ /CFB interface is not the main mechanism for our observations, since the Rashba-split states lead to the opposite direction (and sign) of charge current-induced spin polarization (and  $\theta_{\parallel}$ ) on the basis of the spin structure [27,31]. Instead, we ascertain that the direction of in-plane spin polarization to the electron momentum in our  $\text{Bi}_2\text{Se}_3$ /CFB is consistent with expectations of the TSS of TIs (spin-momentum locking) [12–14,27,31,37]. From further analysis [37], we have found that in our devices a large portion of the charge current flows through the TSS in  $\text{Bi}_2\text{Se}_3$ . The effective  $\theta_{\parallel}$  attributed to only TSS is in the range from  $\sim 1.62 \pm 0.18$  to  $\sim 2.1 \pm 0.39$ .

As mentioned before, the temperature-dependent  $\theta_{\parallel}$  obtained from the above two methods shown in Fig. 3(c) should not show any difference, if  $V_a$  is attributed to only the charge current-induced Oersted field. Therefore, the observed difference implies the existence of other contributions to  $V_a$  (i.e., to  $\tau_{\perp}$ ). For the  $\text{Bi}_2\text{Se}_3$ /CFB system,



the difference can be attributed to the TSS in  $\text{Bi}_2\text{Se}_3$  [23,27,28,31] and/or Rashba-split states at the  $\text{Bi}_2\text{Se}_3$ /CFB interface [29–31]. We analyze  $\Delta\tau = \tau_\perp - \tau_{\text{Oe}}$  as the other contributions to the out-of-plane torque, where  $\tau_\perp$  is the total out-of-plane torque as shown in Fig. 3(b) and  $\tau_{\text{Oe}}$  is a partial out-of-plane torque from the charge current (flowing in  $\text{Bi}_2\text{Se}_3$ ) induced Oersted field. By using the measured  $\theta_\parallel$  by  $V_s$  only, we can deduce  $\tau_{\text{Oe}}$  and thus  $\Delta\tau$  by  $\theta_\parallel = (V_s/V_a^*)(e\mu_0 M_s t d/\hbar)[1 + (4\pi M_{\text{eff}}/H_{\text{ext}})]^{1/2}$ , and  $V_a^* = -(I_{\text{rf}}\gamma \cos \theta_H/4)(dR/d\theta_H)\tau_{\text{Oe}}\{[1 + (\mu_0 M_{\text{eff}}/H_{\text{ext}})]^{1/2}/\Delta\} F_{\text{asym}}(H_{\text{ext}})$  [3,27], where  $V_a^*$  is the equivalent antisymmetric component only due to the current-induced Oersted field ( $\tau_{\text{Oe}}$ ). As shown in Fig. 4(a), the out-of-plane torque ( $\Delta\tau$ ) in all three devices becomes much larger at low temperatures (<50 K), compared to the  $\Delta\tau$  at high temperatures (100–300 K). Consequently, we can obtain the out-of-plane spin-orbit torque ratio ( $\theta_\perp$ ) as a function of temperature by using the same method by which we deduce  $\theta_\parallel$  from  $\tau_\parallel$  above. As shown in Fig. 4(b), we find that  $\theta_\perp$  in all three devices also becomes more significant at low temperatures (<50 K). More interestingly, the  $\theta_\perp$  has the same order of magnitude compared to  $\theta_\parallel$ .

We now discuss the origin of the out-of-plane torque. As has been reported recently, a Rashba-split surface state in two-dimensional electron gas (2DEG) coexists with TSS in the  $\text{Bi}_2\text{Se}_3$  surface due to the band bending and structural inversion asymmetry [29,30,49–52]. The Rashba effective magnetic field can be written as  $H_T = \alpha_R/\hbar(\hat{z} \times k)$  [49–51], where  $\hat{z}$  is a unit vector normal to film plane,  $k$  is the average electron Fermi wave vector, and  $\alpha_R$  is a characteristic parameter of the strength of Rashba splitting in 2DEG. Since the electron Fermi wave vector can be assumed to show a weak temperature dependence and the  $\alpha_R$  decrease as the temperature decreases in a typical 2DEG [53,54],  $H_T$  is expected to decrease as the temperature decreases in these semiconductor systems. In addition, the similar temperature-dependent behavior of  $H_T$  has been recently reported in Ta and CoFeB heterostructures, where  $H_T$  decreases and eventually almost reaches zero at low temperatures [10,35]. However, the observed  $\Delta\tau$  (equivalent to  $H_T$ ) in our  $\text{Bi}_2\text{Se}_3$ /CFB presents the opposite temperature-dependent behavior which is not in line with the reports about Rashba-induced torques. Therefore, we

conclude that the Rashba-split surface state in 2DEG of  $\text{Bi}_2\text{Se}_3$  is not the main mechanism for the out-of-plane torque ( $\Delta\tau$ ).

On the other hand, a possible out-of-plane spin polarization in the TSS has been theoretically predicted [55,56] and experimentally observed in  $\text{Bi}_2\text{Se}_3$  [57,58], which is attributed to the hexagonal warping effect in the Fermi surface [55,59]. This out-of-plane spin polarization in the TSS can account for the observed  $\Delta\tau$  especially in the low temperature range (<50 K), and the  $\Delta\tau$  adds to the  $\tau_{\text{Oe}}$  [27,31]. Moreover, as shown in Figs. 3(a) and 4(a), the out-of-plane torque ( $\Delta\tau$ ) has the same order of magnitude comparable to the in-plane torque ( $\tau_\parallel$ ) below 50 K ( $\Delta\tau/\tau_\parallel \sim 60\%$ ) [37], which is in agreement with the behavior of hexagonal TSS in TI [55,56]. With the analysis from different aspects, our findings especially in the low temperature range (<50 K) indicate a TSS origin of spin-orbit torques in  $\text{Bi}_2\text{Se}_3$  and CFB.

In summary, we have studied the temperature dependence of spin-orbit torques in  $\text{Bi}_2\text{Se}_3$ /CoFeB heterostructures. As the temperature decreases, the spin-orbit torque ratio increases drastically and eventually reaches a maximum value of  $\sim 0.42$ , which is almost 10 times larger than that at 300 K. A significant out-of-plane torque ( $\Delta\tau$ ), in addition to charge current-induced Oersted field torque ( $\tau_{\text{Oe}}$ ), can be observed below 50 K. The observed spin-orbit torques are attributed to the topological surface states in  $\text{Bi}_2\text{Se}_3$ . Our results suggest that topological insulators with strong spin-orbit coupling and spin-momentum locking are promising spin current sources for the next generation of spintronic devices.

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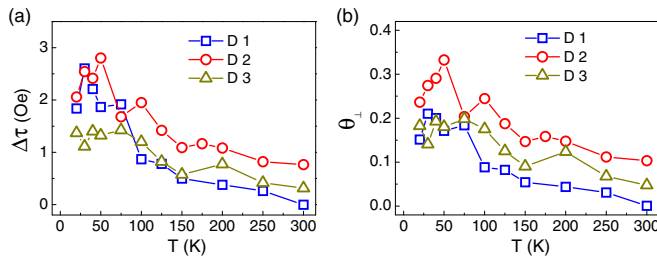


FIG. 4 (color online). (a) Temperature-dependent out-of-plane torque ( $\Delta\tau = \tau_\perp - \tau_{\text{Oe}}$ ) and (b) out-of-plane torque ratio ( $\theta_\perp$ ) in  $\text{Bi}_2\text{Se}_3$ /CFB (5 nm) devices.

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